

**Search Notes**

Application/Control No.

10/534,019

Examiner

Steven D. Maki

Applicant(s)/Patent under  
Reexamination

MIYASAKA, ATSUSHI

Art Unit

1791

**SEARCHED**

Class	Subclass	Date	Examiner
152	209.15		
	209.18		
	209.21		
	209.24		
	Dig.3		
	902		
	903		
updated	above	11/28/2007	<i>SDM</i>

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
PGPUB, USPAT text search - see search history printout		11/28/2007	<i>SDM</i>

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
none	11/28/2007	<i>SDM</i>